

<b>Notice of References Cited</b>	Application/Control No. 10/810,640		Applicant(s)/Patent Under Reexamination HAYASHI ET AL.	
	Examiner Elias Desta		Art Unit 2857	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,829,232	08-1974	Fiegles et al.	415/1
*	B	US-4,455,614	06-1984	Martz et al.	700/288
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Satoh et al., 'Maintenance Scheduling by Using Simulated Annealing Method', 1991, IEEE Article, pages 850-857
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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